



Attorney Docket No. 1670.1015

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yun Soo, CHOE et al.

Application No.: 10/652,493

Group Art Unit: TO BE ASSIGNED

Filed: September 2, 2003

Examiner:

For: HEATING CRUCIBLE FOR ORGANIC THIN FILM FORMING APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure provisions of 37 CFR § 1.56, there is hereby provided certain information which the Examiner may consider material to the examination of the subject U.S. patent application. It is requested that the Examiner make this information of record if it is deemed material to the examination of the subject application.

1. Enclosures accompanying this Information Disclosure Statement are:

- 1a. ☒ Form PTO-1449.
- 1b. ☒ Copies of IDS citations.
- 1c. ☐ An English language copy of search report(s) from a counterpart foreign application or a PCT International Search Report.
- 1d. ☐ English language translation (complete or relevant portion(s)) attached to each non-English language publication.
- 1e. ☒ Explanations of Relevancy of References (ATTACHMENT 1(e), hereto) for providing a concise explanation of each non-English publication.

2. ☒ In accordance with 37 CFR § 1.98, a concise explanation of what is presently understood to be the relevance of each non-English language publication is

(Check appropriate Items 2a, 2b, 2c and/or 2d)


- 2a. ☐ satisfied because all non-English language publications were cited on the enclosed "English-language version of the search report or action which indicates the degree of relevance found by the foreign office". (See MPEP 609, Minimum Requirements for an Information Disclosure Statement, Part A(3): Concise Explanation of Relevance, pp. 600-100 to 600-101, Rev. 1, Feb. 2000.)
- 2b. ☐ set forth in the application.

- 2c. ☐ satisfied because an English language translation (complete or relevant portion(s)) is attached to each non-English language publication.
- 2d. ☒ enclosed as Attachment 1(e), hereto.
3. No admission is made that the information cited in this Statement is, or is considered to be, material to patentability nor a representation that a search has been made (other than search report(s) from a counterpart foreign application or a PCT International Search Report, if submitted herewith). 37 CFR §§ 1.97(g) and (h).

Respectfully submitted,

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P.O. 1449

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

ATTORNEY DOCKET NO.

1670.1015

APPLICATION NO.

10/652,493

FIRST NAMED INVENTOR

Yun Soo, CHOE et al.

FILING DATE

September 2, 2003

GROUP ART UNIT

TO BE ASSIGNED

LIST OF REFERENCES CITED BY APPLICANT

(Use several sheets if necessary)

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NO.	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION	
							YES	NO
	AG	2000-223269	8/11/2000	Japan				X
	AH	2000-12218	1/14/2000	Japan				X
	AI	2000-68055	3/3/2000	Japan				X
	AJ	2000-160328	6/13/2000	Japan				X
	AK	10-195639	7/28/1998	Japan				X
	AL							X

OTHER REFERENCES (INCLUDING AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.)

	AM	
	AN	
	AO	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

**ATTACHMENT 1(e)**

EXPLANATIONS OF RELEVANCY OF REFERENCES	ATTORNEY DOCKET NO. 1670.1015	APPLICATION NO. 10/652,493
	FIRST NAMED INVENTOR Yun Soo, CHOE et al.	
	FILING DATE September 2, 2003	GROUP ART UNIT TO BE ASSIGNED

Patent No.: JP 2000-22369

Date: August 11, 2000

Related to heating crucible for organic thin film forming apparatus

Patent No.: JP 2000-12218

Date: January 14, 2000

Related to heating crucible for organic thin film forming apparatus

Patent No.: 2000-68055

Date: March 3, 2000

Related to heating crucible for organic thin film forming apparatus

Patent No.: JP 2000-160328

Date: June 13, 2000

Related to heating crucible for organic thin film forming apparatus

Patent No.: JP 10-195639

Date: July 28, 1998

Related to heating crucible for organic thin film forming apparatus